

Docket No.: ASMEX.367A

Customer N . 20,995

INFORMATION DISCLOSURE STATEMENT

Applicant : Michael A. Todd
App. No. : 10/074,534
Filed : February 11, 2002
For : PROCESS FOR DEPOSITION OF
SEMICONDUCTOR FILMS
Examiner : Shrinivas H. Rao
Group Art Unit : 2814

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Enclosed is form PTO-1449 listing references that are also enclosed.

This Information Disclosure Statement is being filed with an RCE or within three months of the filing date of this application and no fee is required in accordance with 37 C.F.R. § 1.97(b)(1), (b)(2), or (b)(4).

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: 8/19/03

By: Joseph J. Mallon

Joseph J. Mallon
Registration No. 39,287
Attorney of Record
Customer No. 20,995
(619) 235-8550

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SHEET 1 OF 1

FORM PTO-1449	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY. DOCKET NO. ASMX387A	APPLICATION NO. 10/074,694
INFORMATION DISCLOSURE STATEMENT BY APPLICANT		APPLICANT Michael A. Todd	
(USE SEVERAL SHEETS IF NECESSARY)		FILING DATE February 11, 2002	GROUP 2814

U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (IF APPROPRIATE)
1.	5,214,002	05/25/93	Hayashi et al.			
2.	5,356,821	10/18/94	Naruse et al.			
3.	5,471,330	11/28/95	Sarma			
4.	6,103,600	08/15/00	Ueda et al.			

FOREIGN PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
						YES NO
5.	11317530	16-11-99	Japan (abstract)			X
6.	EP 0368651 A2	16-05-90				
7.	EP 0486047 A2	20-05-92				
8.	EP 0747974 A2	11-12-96				
9.	EP 1065728 A2	03-01-01				
10.	GB 2332564 A	23-06-99	United Kingdom			

EXAMINER INITIAL	OTHER DOCUMENTS (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)
11.	Olivares, J. et al.; "Solid-phase crystallization of amorphous SiGe films deposited by LPCVD on SiO ₂ and glass," Thin Solid Films 337 (1999) pp. 51-54.

S:\DOCS\JOM\JOM-5163.DOC:081903

EXAMINER	DATE CONSIDERED
*EXAMINER: INITIAL IF CITATION CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP 808; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED, INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.	

PATENT

Attorney Docket No.: ASMEX367A

Date: August 19, 2003

Page 1

REQUEST FOR CONTINUED EXAMINATION (RCE)

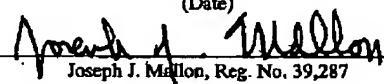
UNDER 37 C.F.R. § 1.114

Applicant: Michael A. Todd
 Application Number: 10/074,534
 Filing Date: February 11, 2002
 Title: PROCESS FOR DEPOSITION OF
 SEMICONDUCTOR FILMS
 Examiner Name: Shrinivas H. Rao
 Group Art Unit: 2814

I hereby certify that this correspondence and all
 marked attachments are being deposited with the
 United States Postal Service as first-class mail in an
 envelope addressed to: Commissioner for Patents,
 P.O. Box 1450, Mail Stop RCE, Alexandria, VA
 22313-1450, on

August 19, 2003

(Date)



Joseph J. Mallon, Reg. No. 39,287

Commissioner for Patents
 P.O. Box 1450
 Mail Stop RCE
 Alexandria, VA 22313-1450

This is a Request for Continued Examination (RCE) under 37 C.F.R. § 1.114 of the above-identified application.

1. Submission Required under 37 C.F.R. § 1.114:

Enclosed:
 Information Disclosure Statement (IDS)
 Return Postcard

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2. Fees:

RCE fee (\$750 large entity)

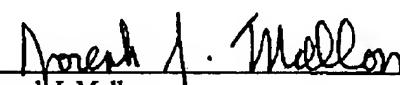
3. Payment:

Check in the amount of \$750 to cover the above fees.
 The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. § 1.16 and § 1.17 which may be required, now or in the future, or credit any overpayment to Deposit Account No. 11-1410.

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Address all future communications to Customer No. 20,995.

Dated: 8/19/03



Joseph J. Mallon
 Registration No. 39,287
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 (619) 235-8550

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TO: Examiner Rao
 FIRM: USPTO
 FACSIMILE No.: 703-746-3926
 OUR REF.: ASMEX.367A
 YOUR REF.: 10/074,534
 FROM: Joseph J. Mallon, Reg. No. 39,287
 OPERATOR: Susan Olson NO. OF PAGES: 4 (incl. cover sheet)
 DATE: December 3, 2003

IF YOU DID NOT RECEIVE ALL OF THE PAGES PLEASE CALL BACK IMMEDIATELY
 OPERATOR PHONE No.: (619) 235-8550 FACSIMILE No.: (619) 235-0176

MESSAGE: Attached please find a courtesy copy of the RCE we filed in the above-referenced matter on August 19, 2003.

Orange County
 949-760-0404

San Francisco
 415-954-4114

Los Angeles
 310-551-3450

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 909-781-9231

San Luis Obispo
 805-547-5580